



Patent
Attorney's Docket No. 015290-506

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)

Ting CHIEN et al.)

Application No.: 09/820,692)

Filed: March 30, 2001)

For: PLASMA ETCHING OF DIELECTRIC LAYER)
WITH SELECTIVITY TO STOP LAYER)

Group Art Unit: 1765

Examiner: K.C. Chen

Confirmation No. 5245

AMENDMENT AFTER FINAL REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed October 7, 2003, please amend the
above-identified application as follows:

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FEB 19 2004

Do not enter.

K-CC

3/4/04